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Substitute for form 1449A/B/PTO			Complete If Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Application Number	10/767,298-Conf.# 5002	
			Filing Date	January 28, 2004	
			First Named Inventor	Lingyi A. Zheng	
			Art Unit	2824-2891	
			Examiner Name	Michael K. Luhrs-	
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (If known)			
CC		US-11/027,825	Filed 12-29-2004	Derderian et al.	
		US-10/933,604	Filed 09-02-2004	Carpenter et al.	
		US-10/687,458	Filed 10-15-2003	Kubista et al.	
		US-10/683,424	Filed 10-10-2003	Mardian	
		US-10/839,316	Filed 05-05-2004	Saragiannis et al.	
		US-10/814,573	Filed 03-31-2004	Gealy et al.	
		US-11/043,629	Filed 01-25-2005	Rueger et al.	
		US-11/018,142	Filed 12-20-2004	Rueger et al.	
		US-10/840,571	Filed 05-06-2004	Dando et al.	
		US-10/859,883	Filed 06-02-2004	Miller et al.	
		US-10/683,606	Filed 10-09-2003	Derderian	
		US-10/733,523	Filed 10-10-2003	Beaman et al.	
		US-11/027,809	Filed 12-29-2004	Carpenter et al.	
		US-579,269	03-23-1897	Hent	
		US-3,618,919	11-09-1971	Beck	
		US-3,620,934	11-16-1971	Endie	
		US-3,630,881	12-28-1971	Lester et al.	
		US-3,630,769	12-28-1971	Hart et al.	
CC		US-3,634,212	01-11-1972	Valayil et al.	

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CC	US-4,018,949	04-19-1977	Donokowski et al.	
↑	US-4,242,182	12-30-1980	Popescu	
	US-4,269,625	05-26-1981	Molenaar	
	US-4,289,061	09-15-1981	Emmett	
	US-4,397,753	08-09-1983	Czaja	
	US-4,438,724	03-27-1984	Doehler et al.	
	US-4,469,801	09-04-1984	Hirai et al.	
	US-4,545,136	10-08-1985	Izu et al.	
	US-4,590,042	05-20-1986	Drage	
	US-4,681,777	07-21-1987	Engelken et al.	
	US-4,826,579	05-02-1989	Westfall	
	US-4,948,979	08-14-1990	Munakata et al.	
	US-4,949,669	08-21-1990	Ishii et al.	
	US-4,966,646	10-30-1990	Zdeblick	
	US-4,977,106	12-11-1990	Smith	
	US-5,076,205	12-31-1991	Vowles et al.	
	US-5,091,207	02-25-1992	Tanaka	
	US-5,131,752	07-21-1992	Yu et al.	
	US-5,136,975	08-11-1992	Bartholomew et al.	
	US-5,172,849	12-22-1992	Barten et al.	
	US-5,200,023	04-06-1993	Gifford et al.	
	US-5,223,113	06-29-1993	Kaneko et al.	
	US-5,232,749	08-03-1993	Gilton	
	US-5,248,527	09-28-1993	Uchida et al.	
	US-5,364,219	11-15-1994	Takahashi et al.	
	US-5,377,429	01-03-1995	Sandhu et al.	
	US-5,380,396	01-10-1995	Shikida et al.	
	US-5,409,129	04-25-1995	Tsukada et al.	
	US-5,418,180	05-23-1995	Brown	
	US-5,427,666	06-27-1995	Mueller et al.	
↓	US-5,433,835	07-18-1995	Demaray et al.	
CC	US-5,445,491	08-29-1995	Nakagawa et al.	

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CC	US-5,480,818	01-02-1996	Matsumoto et al.	
↑	US-5,498,292	03-12-1996	Ozaki	
	US-5,500,256	03-19-1996	Watabe	
	US-5,522,934	06-04-1996	Suzuki et al.	
	US-5,536,317	07-16-1996	Crain et al.	
	US-5,562,800	10-08-1996	Kawamura	
	US-5,589,002	12-31-1996	Su	
	US-5,592,581	01-07-1997	Okase	
	US-5,595,606	01-21-1997	Fujikawa et al.	
	US-5,599,513	02-04-1997	Masaki et al.	
	US-5,624,498	04-29-1997	Lee et al.	
	US-5,626,936	05-06-1997	Alderman	
	US-5,640,751	06-24-1997	Faria	
	US-5,643,394	07-01-1997	Maydan et al.	
	US-5,654,589	08-05-1997	Huang et al.	
	US-5,693,288	12-02-1997	Nakamura	
	US-5,729,896	03-24-1998	Dalal et al.	
	US-5,746,434	05-05-1998	Boyd et al.	
	US-5,766,364	06-16-1998	Ishida et al.	
	US-5,769,952	06-23-1998	Komino	
	US-5,788,778	08-04-1998	Shang et al.	
	US-5,792,700	08-11-1998	Turner et al.	
	US-5,792,269	08-11-1998	Deacon et al.	
	US-5,820,641	10-13-1998	Gu et al.	
	US-5,827,370	10-27-1998	Gu	
	US-5,833,888	11-10-1998	Arya et al.	
	US-5,846,330	12-08-1998	Quirk et al.	
	US-5,846,275	12-08-1998	Lane et al.	
	US-5,851,849	12-22-1998	Comizzoli et al.	
	US-5,865,417	02-02-1999	Harris et al.	
↓	US-5,879,459	03-09-1999	Gadgil et al.	
CC	US-5,895,530	04-20-1999	Shrotriya et al.	

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C C		US-5,908,947	06-01-1999	Vaartstra	
↑		US-5,932,286	08-03-1999	Beinglass et al.	
		US-5,953,634	09-14-1999	Kajita et al.	
		US-5,956,613	09-21-1999	Zhao et al.	
		US-5,968,587	10-19-1999	Frankel	
		US-5,972,430	10-26-1999	DiMeo, Jr. et al.	
		US-5,994,181	11-30-1999	Hsieh et al.	
		US-5,997,588	12-07-1999	Goodwin et al.	
		US-6,008,086	12-28-1999	Schuegraf et al.	
		US-6,032,923	03-07-2000	Biegelsen et al.	
		US-6,042,652	03-28-2000	Hyun et al.	
		US-6,045,620	04-04-2000	Tepman et al.	
		US-6,059,885	05-09-2000	Ohashi et al.	
		US-6,062,256	05-16-2000	Miller et al.	
		US-6,070,551	06-06-2000	Li et al.	
		US-6,080,446	06-27-2000	Tobe et al.	
		US-6,079,426	06-27-2000	Subrahmanyam et al.	
		US-6,086,677	07-11-2000	Umotoy et al.	
		US-6,089,543	07-18-2000	Freerks	
		US-6,109,206	08-29-2000	Maydan et al.	
		US-09/651,037	08-30-2000	Mardian	
		US-6,123,107	09-26-2000	Selser et al.	
		US-6,129,331	10-10-2000	Henning et al.	
		US-6,139,700	10-31-2000	Kang et al.	
		US-6,143,659	11-07-2000	Leem	
		US-6,143,077	11-07-2000	Ikedo et al.	
		US-6,143,078	11-07-2000	Ishikawa et al.	
		US-6,144,060	11-07-2000	Park et al.	
		US-6,149,123	11-21-2000	Harris et al.	
		US-6,160,243	12-12-2000	Cozad	
↓		US-6,161,500	12-19-2000	Kopacz et al.	
C C		US-6,174,366	01-18-2001	Ihantola	

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CC	US-6,174,377	01-16-2001	Doering et al.	
↑	US-6,174,809	01-16-2001	Kang et al.	
	US-6,173,673	01-16-2001	Golovato et al.	
	US-6,178,660	01-30-2001	Emmi et al.	
	US-6,182,603	02-02-2001	Shang et al.	
	US-6,192,827	02-27-2001	Welch et al.	
	US-6,194,628	02-27-2001	Pang et al.	
	US-6,193,802	02-27-2001	Pang et al.	
	US-6,197,119	03-06-2001	Dozoretz et al.	
	US-6,200,415	03-13-2001	Maraschin	
	US-6,203,613	03-20-2001	Gates et al.	
	US-6,206,972	03-27-2001	Dunham	
	US-6,211,078	04-03-2001	Matthews	
	US-6,211,033	04-03-2001	Sandhu et al.	
	US-6,210,754	04-03-2001	Lu et al.	
	US-6,214,714	04-10-2001	Wang et al.	
	US-6,237,394	05-29-2001	Harris et al.	
	US-6,237,529	05-29-2001	Spahn	
	US-6,245,192	06-12-2001	Dhindsa et al.	
	US-6,255,222	07-03-2001	Xia et al.	
	US-6,263,829	07-24-2001	Schneider et al.	
	US-2001/0010309-A1	08-02-2001	Van Bilsen	
	US-6,270,572	08-07-2001	Kim et al.	
	US-2001/0011526-A1	08-09-2001	Doering et al.	
	US-6,280,584	08-28-2001	Kumar et al.	
	US-6,287,980	09-11-2001	Hanazaki et al.	
	US-6,287,965	09-11-2001	Kang et al.	
	US-6,291,337	09-18-2001	Sidhwa	
	US-6,290,491	09-18-2001	Shahvandi et al.	
	US-2001/0024387-A1	09-27-2001	Raaijmakers et al.	
√	US-6,297,539	10-02-2001	Ma et al.	
CC	US-6,302,964	10-16-2001	Umotoy et al.	

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CC	US-6,302,965	10-16-2001	Umotoy et al.	
↑	US-6,303,953	10-16-2001	Doan et al.	
	US-2001/0029892-A1	10-18-2001	Cook et al.	
	US-6,305,314	10-23-2001	Sneh et al.	
	US-6,309,161	10-30-2001	Hofmeister	
	US-6,315,859	11-13-2001	Donohoe	
	US-2001/0045187-A1	11-29-2001	Uhlenbrock	
	US-6,329,297	12-11-2001	Balish et al.	
	US-2001/0054484-A1	12-27-2001	Komino	
	US-2002/0007790-A1	01-24-2002	Park	
	US-6,342,277	01-29-2002	Sherman	
	US-6,346,477	02-12-2002	Kaloyeros et al.	
	US-6,347,602	02-19-2002	Goto et al.	
	US-6,347,918	02-19-2002	Blahnik	
	US-2002/0020353-A1	02-21-2002	Redemann et al.	
	US-6,355,561	03-12-2002	Sandhu et al.	
	US-6,358,323	03-19-2002	Schmitt et al.	
	US-2002/0043216-A1	04-18-2002	Hwang et al.	
	US-6,374,831	04-23-2002	Chandran et al.	
	US-2002/0052097-A1	05-02-2002	Park	
	US-6,387,185	05-14-2002	Doering et al.	
	US-6,387,207	05-14-2002	Janakiraman et al.	
	US-2002/0076508-A1	06-20-2002	Chiang et al.	
	US-2002/0076490-A1	06-20-2002	Chiang et al.	
	US-2002/0073924-A1	06-20-2002	Chiang et al.	
	US-2002/0076507-A1	06-20-2002	Chiang et al.	
	US-6,420,230	07-16-2002	Derderian et al.	
	US-6,419,462	07-16-2002	Horie et al.	
	US-6,420,742	07-16-2002	Ahn et al.	
	US-2002/0094689-A1	07-18-2002	Park	
↓	US-2002/0100418-A1	08-01-2002	Sandhu et al.	
CC	US-6,428,859	08-06-2002	Chiang et al.	

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CC	US-2002/0104481-A1	08-08-2002	Chiang et al.	
↑	US-6,432,831	08-13-2002	Dhindsa et al.	
	US-6,432,259	08-13-2002	Noorbaksh et al.	
	US-6,432,256	08-13-2002	Raoux	
	US-2002/0110991-A1	08-15-2002	Li	
	US-2002/0108714-A1	08-15-2002	Doering et al.	
	US-6,435,865-B1	08-20-2002	Tseng et al.	
	US-6,444,039	09-03-2002	Nguyen	
	US-2002/0127745-A1	09-12-2002	Lu et al.	
	US-6,450,117	09-17-2002	Murugesht et al.	
	US-6,451,119	09-17-2002	Sneh et al.	
	US-2002/0129768-A1	09-19-2002	Carpenter et al.	
	US-6,458,416	10-01-2002	Derderian et al.	
	US-6,461,931	10-08-2002	Eldridge	
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	US-2002/0146512-A1	10-10-2002	Rossman	
	US-2002/0164420-A1	11-07-2002	Derderian et al.	
	US-2002/0162506-A1	11-07-2002	Sneh et al.	
	US-2002/0185067-A1	12-12-2002	Upham	
	US-2002/0195201-A1	12-26-2002	Beer	
	US-2002/0197402-A1	12-26-2002	Chiang et al.	
	US-2002/0195056-A1	12-26-2002	Sandhu et al.	
	US-2003/0003730-A1	01-02-2003	Li	
	US-2003/0000473-A1	01-02-2003	Chae et al.	
	US-2003/0003697-A1	01-02-2003	Agarwal et al.	
	US-6,503,330	01-07-2003	Sneh et al.	
	US-6,506,254	01-14-2003	Bosch et al.	
	US-2003/0013320-A1	01-16-2003	Kim et al.	
	US-6,509,280	01-21-2003	Choi	
✓	US-2003/0023338-A1	01-30-2003	Chin et al.	
CC	US-2003/0024477-A1	02-06-2003	Okuda et al.	

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CC		US-2003/0027428-A1	02-06-2003	Ng et al.	
↑		US-2003/0027431-A1	02-06-2003	Sneh et al.	
		US-10/365,085	02-11-2003	Carpenter et al.	
		US-2003/0037729-A1	02-27-2003	DeDontney et al.	
		US-6,534,395	03-18-2003	Werkhoven et al.	
		US-6,534,007	03-18-2003	Blonigan et al.	
		US-2003/0060030-A1	03-27-2003	Lee et al.	
		US-6,540,838	04-01-2003	Sneh et al.	
		US-6,541,353	04-01-2003	Sandhu et al.	
		US-2003/0066483-A1	04-10-2003	Lee et al.	
		US-2003/0070618-A1	04-17-2003	Campbell et al.	
		US-2003/0070617-A1	04-17-2003	Kim et al.	
		US-2003/0070609-A1	04-17-2003	Campbell et al.	
		US-6,551,929	04-22-2003	Kori et al.	
		US-2003/0075273-A1	04-24-2003	Kilpela et al.	
		US-2003/0079686-A1	05-01-2003	Chen et al.	
		US-6,562,140	05-13-2003	Bondestam et al.	
		US-6,562,141	05-13-2003	Clarke	
		US-2003/0098372-A1	05-29-2003	Kim	
		US-2003/0098419-A1	05-29-2003	Ji et al.	
		US-6,573,184	06-03-2003	Park	
		US-2003/0106490-A1	06-12-2003	Jallepally et al.	
		US-6,579,372	06-17-2003	Park	
		US-6,579,374	06-17-2003	Bondestam et al.	
		US-2003/0121608-A1	07-03-2003	Chen et al.	
		US-6,596,085	07-22-2003	Schmitt et al.	
		US-6,602,346	08-05-2003	Gochberg	
		US-2003/0159780-A1	08-28-2003	Carpenter et al.	
		US-10/665,908	09-18-2003	Sarigiannis et al.	
		US-6,630,201	10-07-2003	Chiang et al.	
↓		US-2003/0194862-A1	10-16-2003	Mardian et al.	
CC		US-2003/0192645-A1	10-16-2003	Liu	

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CC	US-6,635,965	10-21-2003	Lee et al.	
↑	US-6,638,879	10-28-2003	Hsieh et al.	
	US-6,638,672	10-28-2003	Deguchi	
	US-2003/0203109-A1	10-30-2003	Dando et al.	
	US-2003/0200926-A1	10-30-2003	Dando et al.	
	US-6,641,673	11-04-2003	Yang	
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	US-2004/0003777-A1	01-08-2004	Carpenter et al.	
	US-2004/0007188-A1	01-15-2004	Burkhart et al.	
	US-2004/0035358-A1	02-26-2004	Basceri et al.	
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	US-2004/0083959-A1	05-06-2004	Carpenter et al.	
	US-2004/0083961-A1	05-06-2004	Basceri	
	US-2004/0083960-A1	05-06-2004	Dando	
	US-2004/0099377-A1	05-27-2004	Newton et al.	
	US-2004/0124131-A1	07-01-2004	Aitchison et al.	
	US-2004/0154538-A1	08-12-2004	Carpenter et al.	
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	US-2004/0226507-A1	11-18-2004	Carpenter et al.	
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